# Electron Microscopy Center Proposal



EMC Use Only	Proposal Number	Date Submitted	Proposal Status	
You have logged-in to the EMC Proposal Database.				
You must c	lick the "Log Out"	' button before you cl	ose this browser window.	
1. To start, click the "New Record" button in the area to the left of this window. It looks like this:				
2. Netscape: a text insertion bar will not be visible in the tables. Just click in the tables and type.				
3. You have 1 hour to c	omplete the propos	Sal. 		
1. Proposal Type:				
_		<u>-</u>		
2. Project Title:				
3. Researchers:				
<u>Primary User:</u>				
ANL-assigned badge	a #			
First/given nam				
Last/family nan				
Home institution	on:			
Location of hor institution		country:		
Telephor	ne:			
Ema	ail:			
Employment lev	/el:			
Employer classification	on:			
Citizenship (countr				
Gend	er: O Female O I	Male		
Ethnici	ty:			
Date of bir	th:	( month/day/year, e.g.	12/25/1965 )	
Additional information	on Division:		Group Name:	
for ANL employees:	Building:		Group Leader:	

## Co-investigators, collaborators, advisor:

Check "request in lab – yes" for those collaborators who want to be in the EMC labs for experiments. All persons who will be in the EMC labs must register with Argonne National Laboratory's National User Facilities at:

http://www.anl.gov/Science\_and\_Technology/userreg.html

The Primary User is responsible for notifying all in-lab collaborators of this requirement.

First	Name	Last Name	Institution		US state or Country	Email	Reque In-Lal
							□Yes
							□ Yes
							□ Yes
							□ Yes
				-			
I. Proj	ect Des	cription:					
EMC sta	aff with wl	nom you have discus	ssed this project:				
s the pr	oposed p	roject proprietary?	O Yes O No			nd nonproprietary into different prop	
Select a	ll of the re	esearch subject cate	gories that apply to	this pro	posal:		
	□Materi	als sciences (include	es condensed matte	r physic	s and materia	ıls chemistry)	
	☐ Physics (excludes condensed matter physics)						
	☐ Chemistry (excludes materials chemistry)						
	□ Polymers						
	☐ Medic	al applications					
	☐ Biological and life sciences (excludes medical applications)						
	☐ Earth	sciences					
	☐ Enviro	nmental sciences					
	Optics	•					
	☐ Engine	eering					
	☐ User f	acility (EMC) instrum	entation or techniq	ue deve	lopment		
	☐ Other						
Provide	an abstra	act or short summary	of the proposed re	search.	Include the s	cientific motivatio	n
pehind the proposed research. Describe why the proposed research is important.							

Provide an abstract or short summary of the proposed research. Include the scientific motivation behind the proposed research. Describe why the proposed research is important.

Describe any preliminary research that you have performed related to this project. Include references to your relevant publications, reports, or conference presentations if this proposal is a continuation of prior work at the EMC.
Is research related to this project also being done at APS, IPNS, or CNM? Check all that apply and enter the proposal numbers, if known.
Facility Proposal? Proposal Numbers  APS Yes IPNS Yes CNM Yes
Describe the key issues you would like to address through the use of EMC resources.
Describe your specimens. Include compositions, preparation methods, and whether they are magnetic (or
can be magnetized).

E Cofoty.
5. Safety:
What hazards (toxic, carcinogenic, radioactive, explosive, pressure, etc.) are associated with the specimen materials or other aspects of your proposed research?
promise materials of other appeals of your proposed resource.
6. Requested EMC Resources:
☐ IVEM-Tandem Facility ★ Note:  ☐ Specimen preparation facilities If you are requesting only the IVEM-
Tandem Facility, check the IVEM-
☐ Philips CM30T AEM  Tandem box at the left and skip the rest of section 6.
□ JEOL JEM-4000EXII HREM
☐ FEI Tecnai F20ST AEM
☐ Zeiss 1540XB FIB
☐ Hitachi S-4700-II FEG SEM Itemize other resources:
☐ FEI Quanta-400 FEG ESEM
☐ Other (itemize)
For each resource that you request ( <u>not</u> the IVEM-Accelerator Facility), summarize the <b>experiments</b> to be performed and the <b>time</b> requested (hours/week or hours/month for a period of X months). Please be
specific for your proposed research, indicating performance requirements (e.g. resolution), special mode
and accessories (e.g. hot/cold stage) that provide justification for resource allocation. Indicate the extent of any specimen preparation that you will need to accomplish in the EMC.

# 7. User Training Information:

Provide the following information for each person who will use EMC instruments.

Academic training in electron microscopy:	
Experience (hands-on) for each resource and technique requested. Please be as specific as possible (types and models of instruments, how often used, over what period of time, etc.):	
Has each person who will use EMC instruments received instrument-specific training by EMC staff for each resource requested (required for user-operation)?	
Specify the instruments for which additional training is needed:	
8. Funding Sources:	
Indicate all of the funding sources for this research:	
☐ DOE Office of Basic Energy Sciences	
☐ DOE Office of Biological & Environmental Research	
□NNSA	
☐ DOE other (includes LDRD)	
☐ Homeland Security	
□DOD	
□NSF	
□NIH	
□NASA	
□USDA	
☐ Other U.S. government	
☐ U.S. industry	
□ Foreign	
☐ Other	

#### 9. IVEM-Tandem Facility Additional Information:

Discuss why you need as much time as you are requesting:

This section must be completed by all those who want to use the IVEM-Tandem Facilities in their research. Other people should skip this section.

Ion Species: Ion Energies:			
Specimen holders, etc. :	☐ Double-tilt heating	☐ Single-tilt straining & heating	
	☐ Double-tilt He-cooled	☐ Single-tilt electrical biasing & heating	
	☐ Tilt-rotate ambient	☐ EDXS system	
	☐ Gatan 622 video camera		
Other IVEM resources:  Number of 8-hour shifts requested:  Preferred dates and grouping of shifts:			
Discuss the motivation for the specific ion beam and experimental requirements:			
Discuss why in situ irradiations are necessary for your project:			

## 10. User Agreement:

This proposal is for access to and use of the facilities and resources available in the Electron Microscopy Center at Argonne National Laboratory. Users who carry out proprietary work under this agreement will be charged an hourly fee that is based on full cost recovery. Users who carry out nonproprietary and publicly-disseminated work under this agreement will not be charged an hourly fee.

This proposal will remain active for a maximum period of one year following the approval date. Following these experiments, a research summary and progress report plus reprints and the full citation information for any publications or presentations must be provided.

A requirement of this agreement is that users acknowledge all work carried out in the EMC in all publications. Any acknowledgment should contain the following information: "... was carried out in the Electron Microscopy Center at Argonne National Laboratory, which is supported by the DOE Office of Science under contract #W-31-109-Eng-38."

EMC staff frequently make major contributions to the research of EMC users through planning and execution of experiments, analysis and interpretation of data, or through collaboration and assistance in the research. It is expected that staff members will be appropriately acknowledged and/or included as coauthors.

Users agree to follow all written User Guides, Standard Operating Procedures, posted notices, and verbal instructions of EMC staff regarding laboratory practices and instrument operation. In any situation that a user feels uncertain about the safe and appropriate operation of an instrument, the user must consult with EMC staff. Failure to follow appropriate procedures and instructions may result in termination of user privileges. Users may be charged for costs associated with repair or replacement of equipment resulting from misuse and/or abuse.

Type your name here if you understand and will comply with the terms of the User Agreement:

Date:

#### Submit the finished proposal and log out.

Click the "Submit" button in the area to the left of this window and then click the "Log Out" button in the same area.





